

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application. No. : 10/822,343
First Named Inventor : Meng Tao
Filed : April 12, 2004
Title : SUPPRESSION OF CHEMICAL REACTIVITY ON SEMICONDUCTOR SURFACES
Art Unit : 2813
Examiner : Not Yet Assigned

REQUEST FOR CORRECTION OF OFFICIAL FILING RECEIPT

Office of Initial Patent Examination's
Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
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Sir:

Applicants in the above-identified patent application request that the Filing Receipt be corrected to show the correct title that is SUPPRESSION OF CHEMICAL REACTIVITY ON SEMICONDUCTOR SURFACES.

A copy of the original filing receipt is enclosed showing the correction marked thereon.

Please issue a corrected filing receipt showing the corrected title as provided herein.

It is believed that no fee is required for the correction; however, if this is incorrect, please charge any fees due for the requested corrected Filing Receipt to Deposit Account 07-0153.

Respectfully submitted,

GARDERE WYNNE SEWELL LLP

Date: August 30, 2004

Intellectual Property
1601 Elm Street, Suite 3000
Dallas, Texas 75201
Telephone: (214) 999-4330
Facsimile: (214) 999-3623

Monique A. Vander Molen
Monique A. Vander Molen
Reg. No. 53,716

AGENT FOR APPLICANTS

124263-1020



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/822,343	04/12/2004	2813	728	124263-1020	9	39	7

CONFIRMATION NO. 3111

FILING RECEIPT



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THOMAS C. WRIGHT
 GARDERE WYNNE SEWELL LLP
 SUITE 3000
 1601 ELM STREET
 DALLAS, TX 75201-4761

Date Mailed: 06/30/2004

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Applicant(s)

Meng Tao, Colleyville, TX;
 Wiley P. Kirk, Garland, TX;

Assignment For Published Patent Application

Board of Regents, The University of Texas System, Austin, TX;

Domestic Priority data as claimed by applicant

This application is a CIP of 10/377,015 02/28/2003

Foreign Applications

If Required, Foreign Filing License Granted: 06/29/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

** SMALL ENTITY **

Title

*surfaces*Suppression of chemical reactivity on semiconductor ~~surface~~**Preliminary Class**

438

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